

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT Application of: )  
Shunpei YAMAZAKI et al. )  
Serial No. 10/081,767 ) ISSUE BRANCH  
Filed: February 27, 2002 )  
For: METHOD OF MANUFACTURING A SEMICONDUCTOR )  
FILM WITH LITTLE WARP )

**PETITION FOR WITHDRAWAL FROM ISSUE  
TO PERMIT CONSIDERATION OF INFORMATION  
DISCLOSURE STATEMENT UNDER  
SECTION 1.97 IN A CONTINUING APPLICATION**

**RECEIVED**

JUL 15 2004

**OFFICE OF PETITIONS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

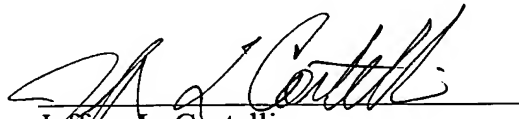
Applicants hereby petition for the withdrawal of this application from issue. The issue fee for this case was paid on June 24, 2004..

The reason for withdrawal from issue of this application is for consideration of information in a continuing application. The continuing application is filed as a Request for Continued Examination (RCE). The RCE, which is entitled to priority under 35 U.S.C. 120 from this application, is being filed on the same date as this petition and accompanies this petition.

The petition fee of \$130 under 37 C.F.R. 1.17(i) is enclosed. The Commissioner is authorized to charge the Petition Fee of \$130.00 or any deficiencies (except the issue fee) or credit any overpayment to Deposit Account No. 19-2380 (740756-2443). A duplicate copy

07/16/2004 AKELLEY 10000011 192380 10081767  
of this sheet is attached.  
01 FC:1460 130.00 DA

Respectfully submitted,

  
Jeffrey L. Costellia  
Registration No. 35,483

NIXON PEABODY LLP  
401 9<sup>TH</sup> STREET, N.W., SUITE 900  
Washington, D.C. 20004 - 2/28  
(202) 585-8000